

# Radiation Tolerance of DEPFET Active Pixel Sensors

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## ● Overview

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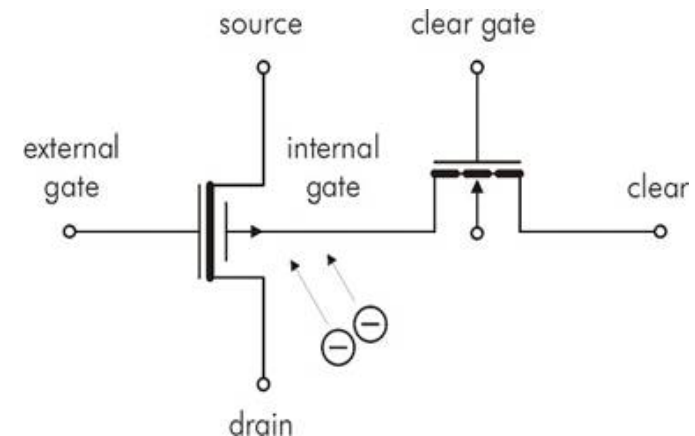
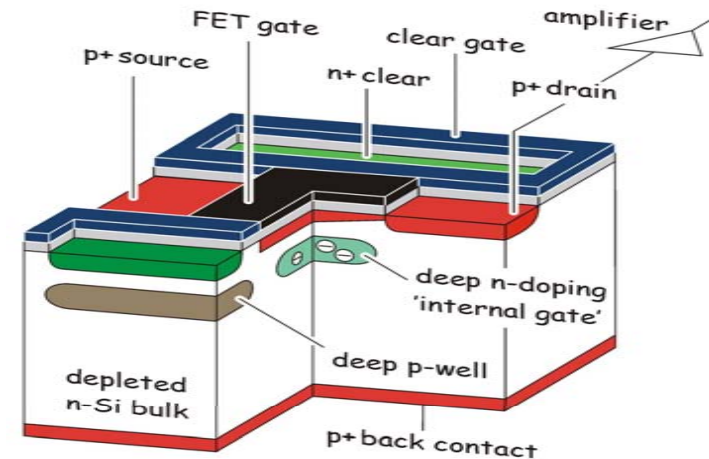


- DEPFET principle
- DEPFET as vertex detector for ILC
- Requirements with respect to radiation hardness
- Investigations of irradiated structures

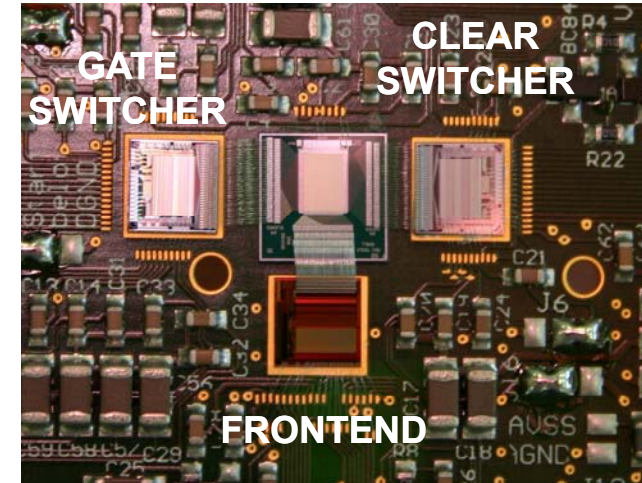
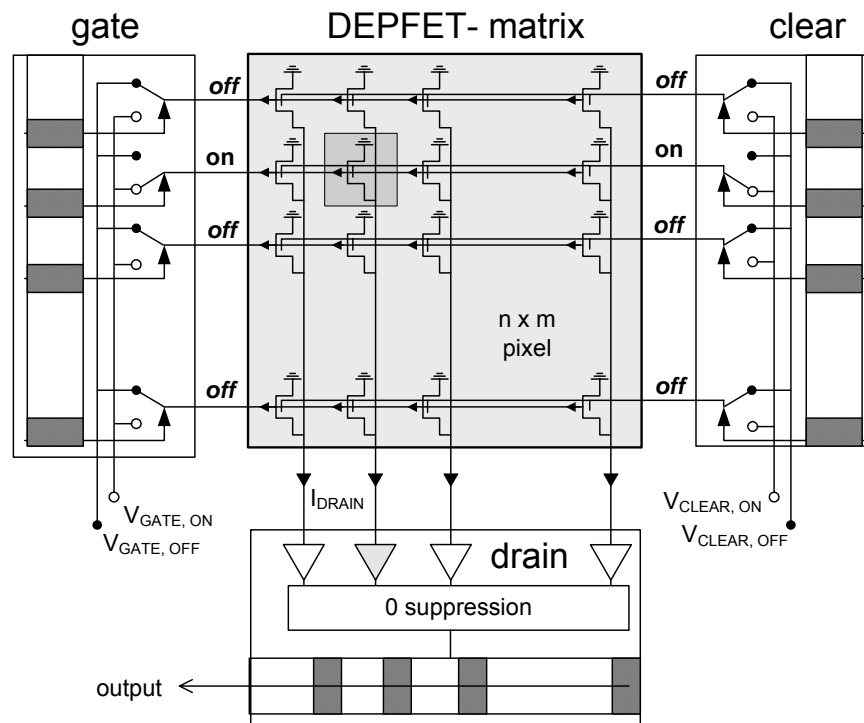
# ● DEPFET - Depleted Field Effect Transistor



- Combination of detector grade silicon with first **p-FET** amplification stage in each pixel
  - **Potential minimum for electrons** is created under the channel by **sideward depletion** and an additional **n-doping**
  - Electrons in the “internal gate” **modulate the transistor current**
  - Signal charge is removed via a clear contact
- 
- **Large sensitive volume** due to **fully depleted** bulk
  - **Low noise** caused by a small input capacitance and **internal amplification**
  - Transistor can be **switched off** by external gate – charge collection is then still active!

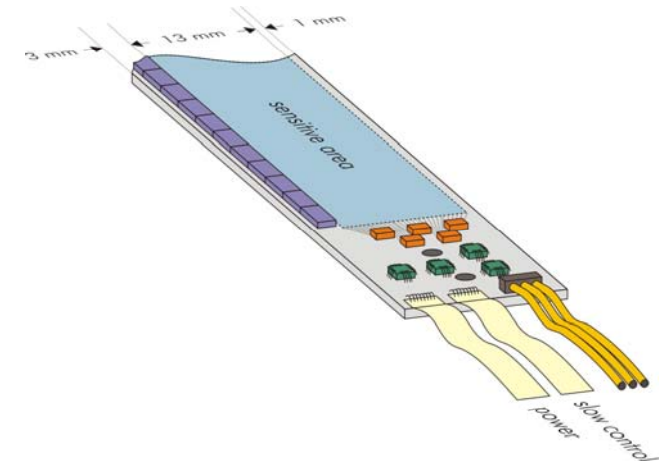
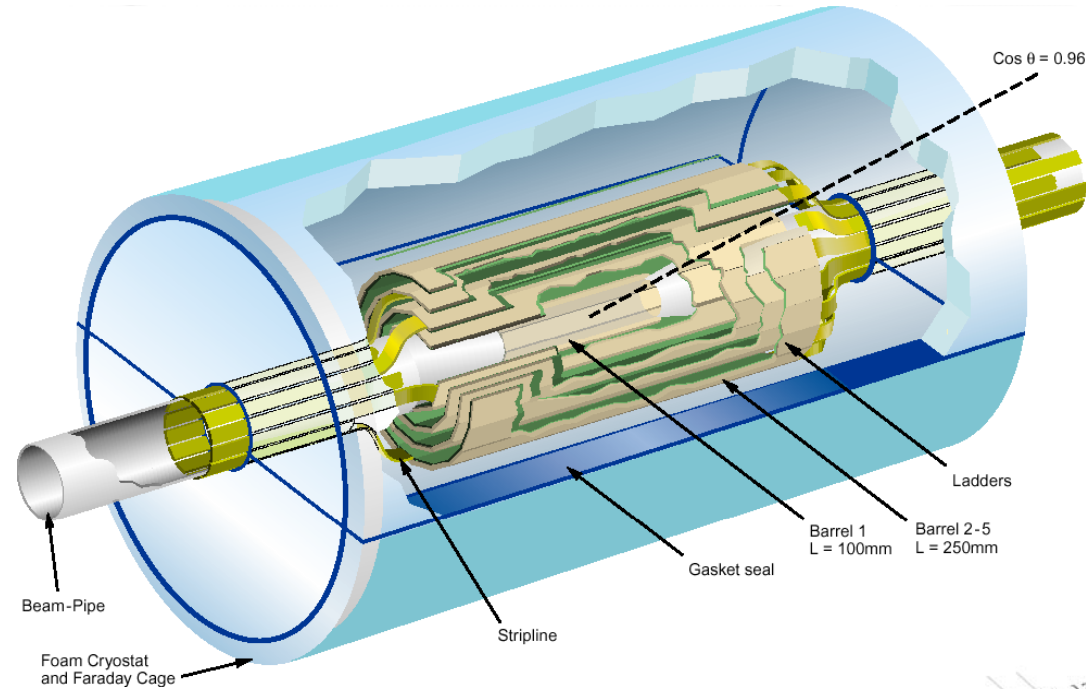


# ● DEPFET - Matrix operation



- Column parallel architecture for fast readout
- Row wise readout operation: Sample-Clear-Sample – no charge transfer
- Low power dissipation – only one row active while readout

- DEPFET as vertex detector for ILC



- IP resolution:  $\sigma_d \leq 5 \mu\text{m} \oplus \frac{10 \mu\text{m}}{p \cdot \sin^2 \vartheta} \text{ GeV}/c$  [Tesla TDR]
  - Good point resolution
  - Small material budget 0.1 %  $X_0$  per layer
- Frame rate ~ 20kHz – line rate 20MHz
- Sufficient radiation hardness

## ● ILC conditions

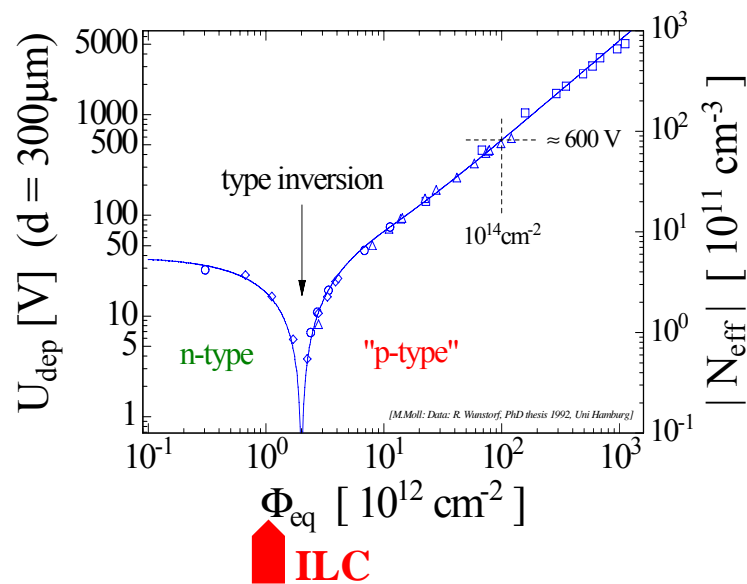


- **e** from Beamstrahlung
- **n** backscattered from the calorimeter
- Total dose around 360krad in 10 years [LDC DOD]
- Moderate cooling with cold gas stream

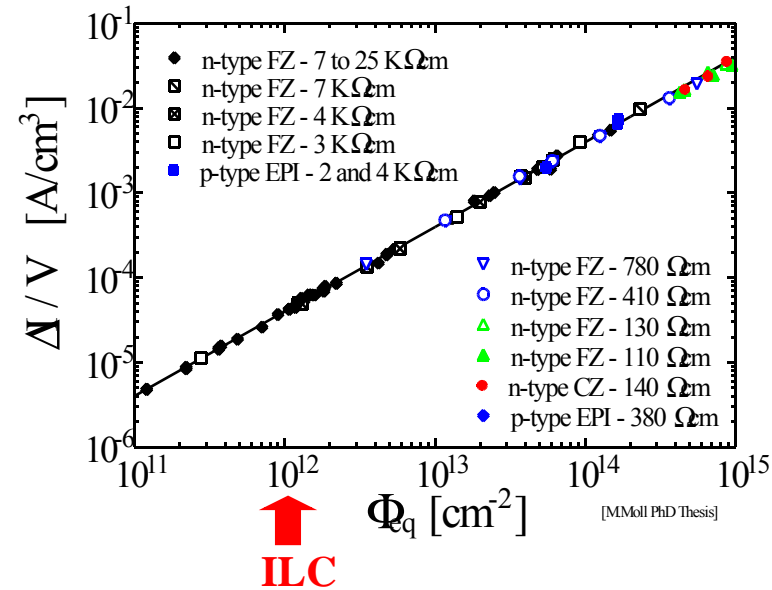
<b>Expected flux:</b>	$1.7 \cdot 10^{12}$ e/cm <sup>2</sup> /year	@ 10MeV [LDC DOD]
	$10^9$ n/cm <sup>2</sup> /year	@ 1MeV n equiv. [LDC DOD]
$\Sigma$ ( <b>e- + n</b> )	$8.5 \cdot 10^{10}$ /cm <sup>2</sup> /year	@ 1MeV n equiv. [LDC DOD]

# Motivation

$U_{\text{dep}}/N_{\text{eff}}$  vs. Dose:



Leakage vs. Dose:

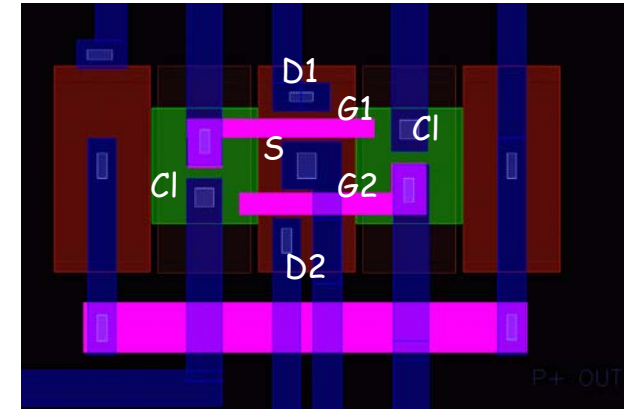


- Space charge sign inversion is not expected to be a problem
- BUT: Several remaining questions:
  - Noise contribution from leakage current? (50 $\mu$ s integration time)
  - What is the extend of the threshold voltage shift?
  - Does the performance of the FET degrade under irradiation?

# ● Overview



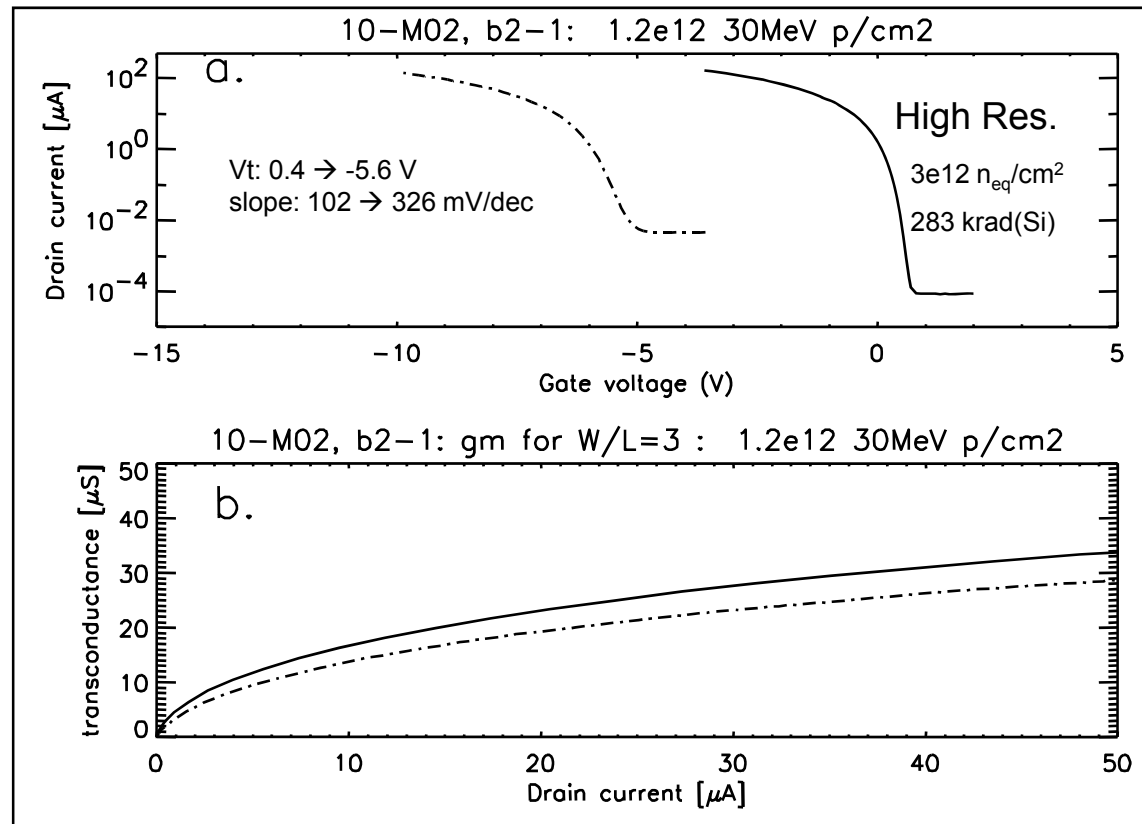
- Single pixel structures with 6µm gate length
- Current based readout
- Characterization with respect to:
  - Electric characteristics ( $V_{th}$ ,  $g_m$ ,  $g_q$ )
  - Leakage current (NIEL)
  - Spectroscopic performance
  - Noise power density (1/f noise)



Type	Protons @ 30MeV	Neutrons @ 1-20MeV	Gammas - Co60
Dose	$1.2 * 10^{12}$ p/cm <sup>2</sup>	$1.6 * 10^{11}$ n/cm <sup>2</sup>	913kRad
1MeV n equivalent	$3 * 10^{12}$	$2.4 * 10^{11}$	
ILC – expectation [LDC DOD]	1MeV n equivalent: $8.5 * 10^{10}$ /cm <sup>2</sup> /year		
ILC operation	35 years	3 years	



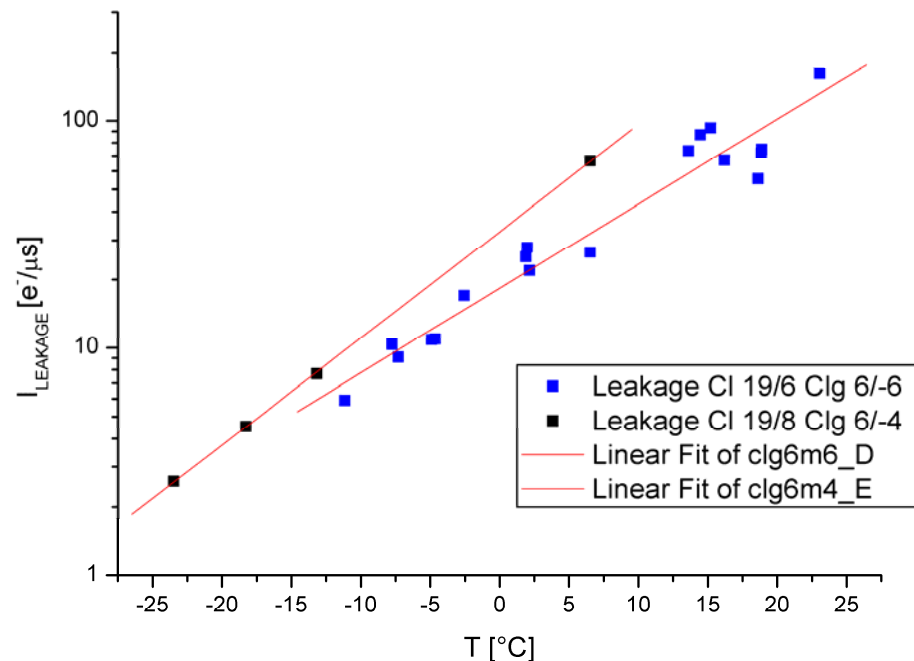
# ● p-irradiated - Electric characteristics



all terminals grounded during irradiation, 30 MeV p

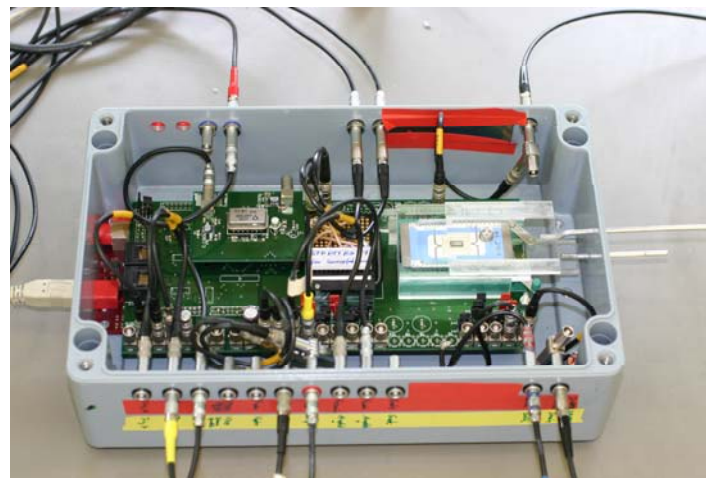
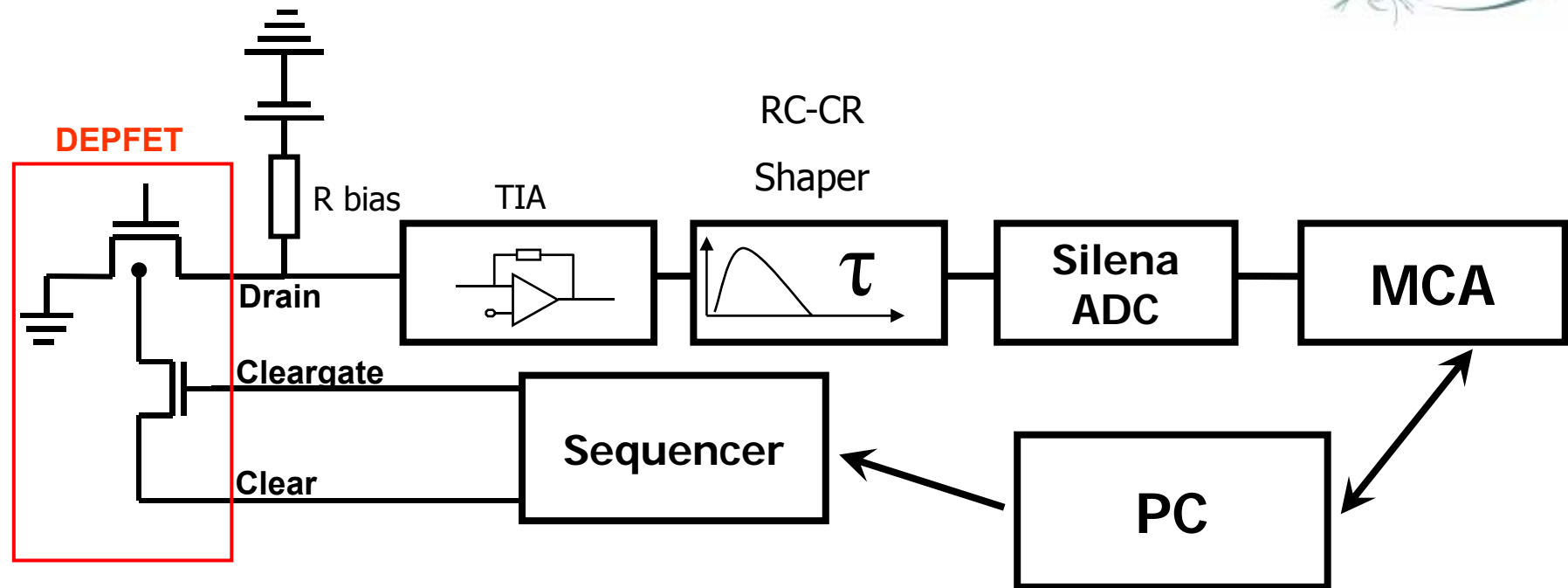
- Threshold voltage shift small compared to the expectations for a dielectric exceeding 200nm
- Increase of sub threshold slope indicate a increase of 1/f-noise
- $g_m$  is noticeably reduced by 15%

# ● p-irradiated - Leakage - Temperature dependence

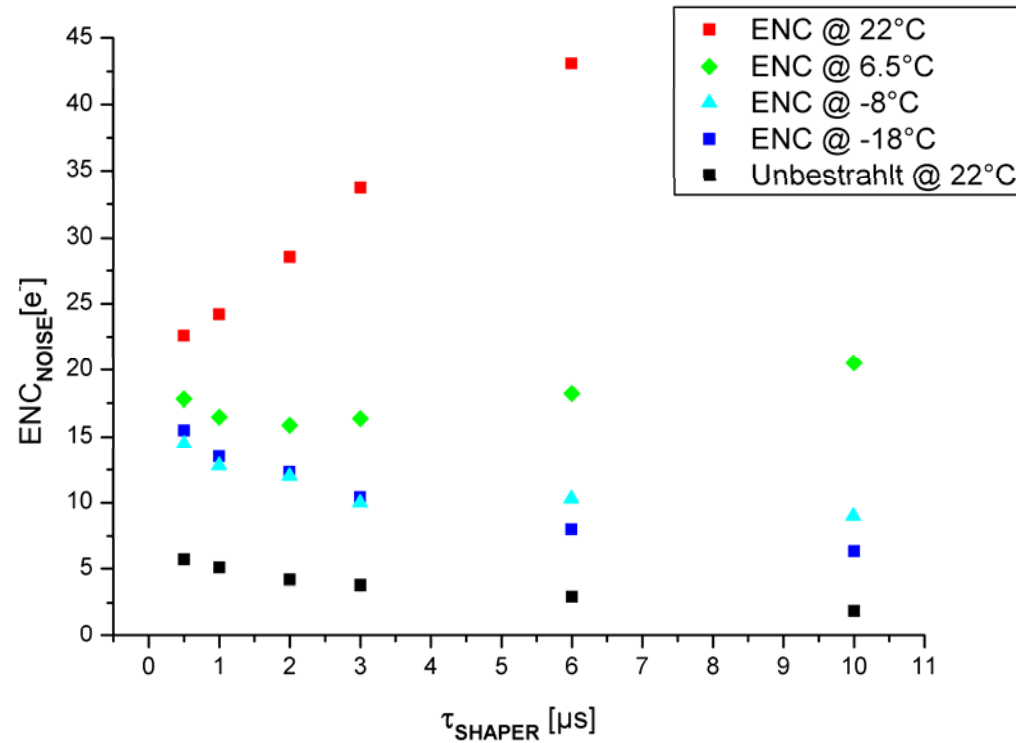


- Dependence on operation voltages -> additional contribution which is not bulk generated
- Thick detector, bulk generated current will decrease with thickness
- At 0°C around 20e/μs! -> L=50μs -> 31e contribution to noise
- Irradiation far beyond 10 years of ILC operation

- Spectroscopy setup

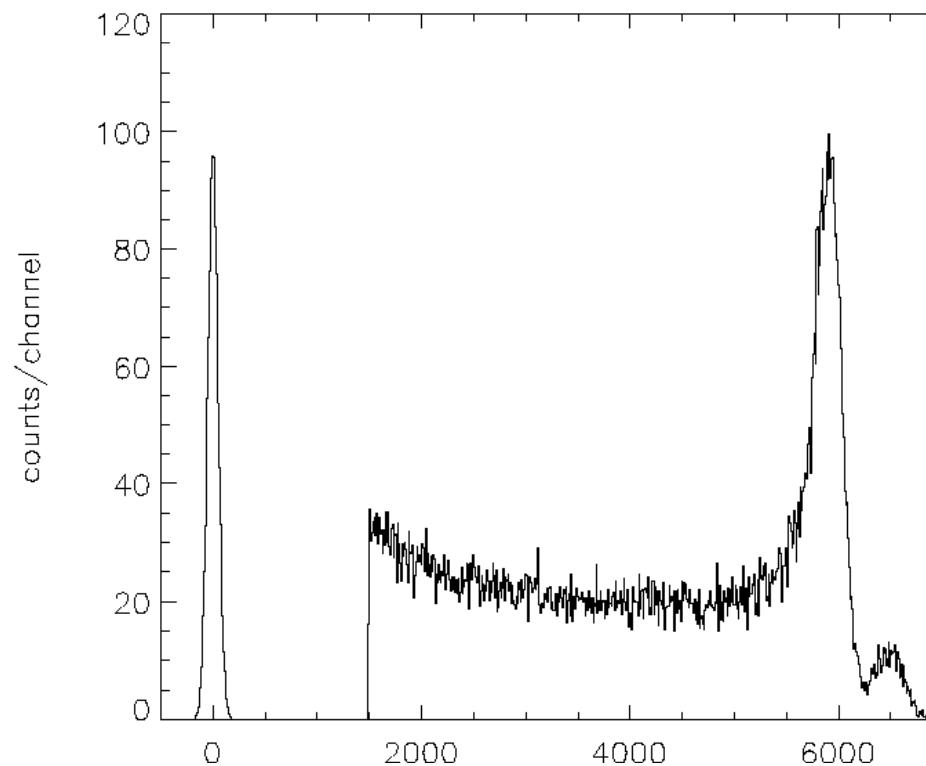
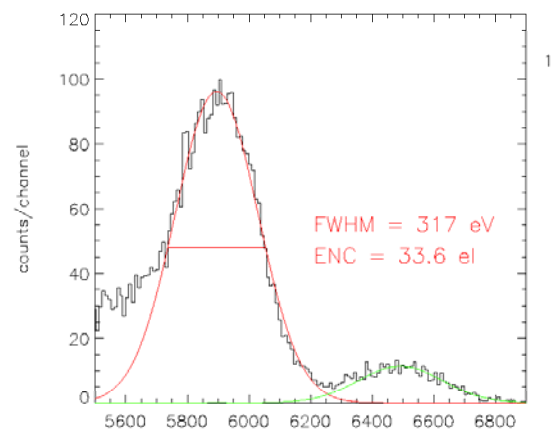
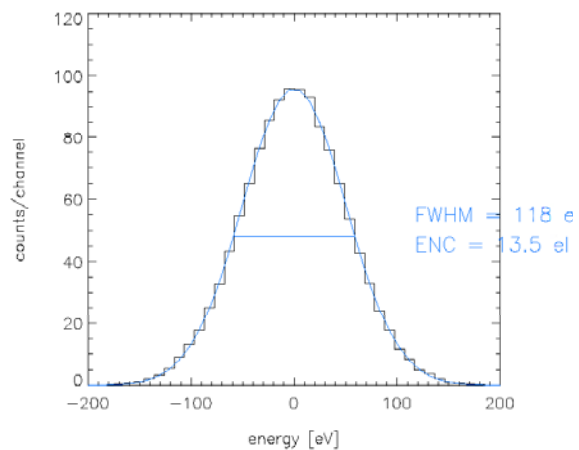


# ● p-irradiated sample - Spectroscopic performance



$$ENC = \sqrt{\underbrace{aC_{tot}^2 A_1 \frac{1}{\tau}}_{\text{Therm. noise}} + \underbrace{2\pi a_f A_2 C_{tot}^2}_{1/f} + \underbrace{eI_{leak} A_3 \tau}_{I_L}}$$

- p-irradiated; Fe55 spectrum



- Good spectroscopic performance!
- Separated Ka Kb peak!

**T=1μs T=-10°C**

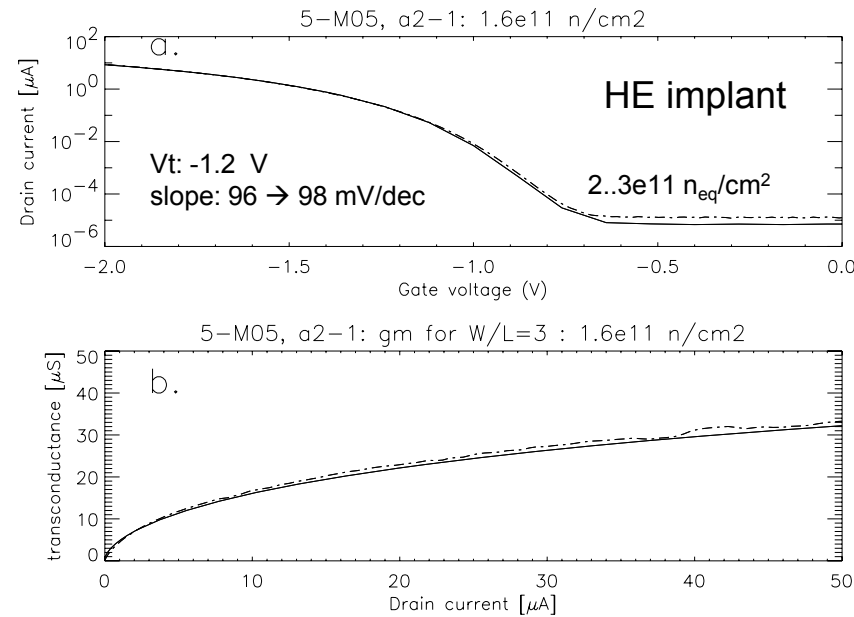
**ENC<sub>noi</sub> = 13.5e<sup>-</sup>**

## ● p - Irradiation - Summary



- DEPFET fully operable after  $3 \cdot 10^{12} n_{eq}/cm^2$
- Threshold voltage shift acceptable
- Gm slightly decreased by 15%
- Noise contribution due to leakage current is tolerable

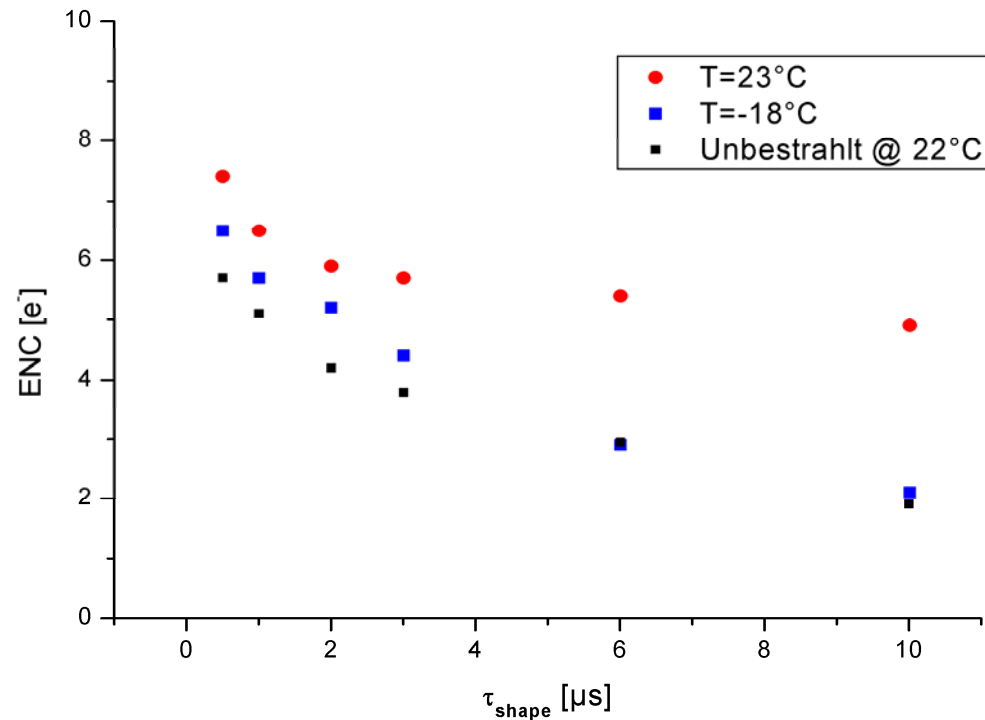
# ● n irradiated - Electrical characteristic



all terminals grounded during irradiation,  
1-20 MeV neutrons (LBNL)

- No threshold voltage shift observed!
- No significant increase in subthreshold slope!

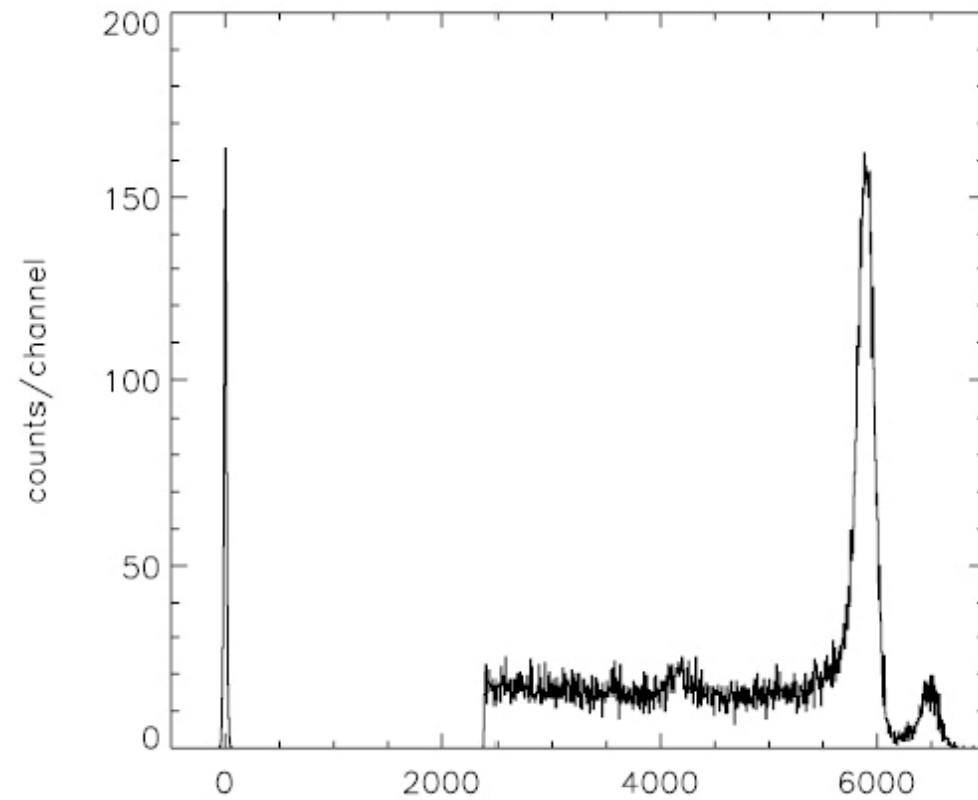
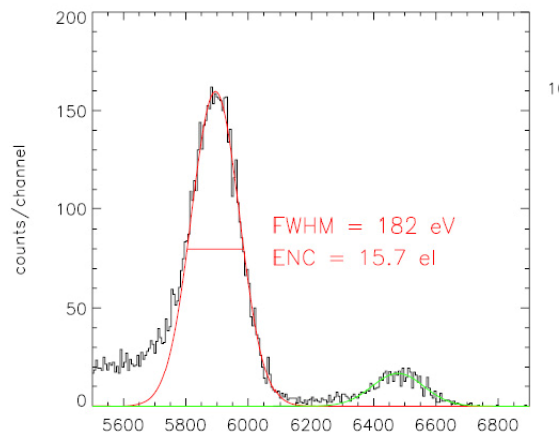
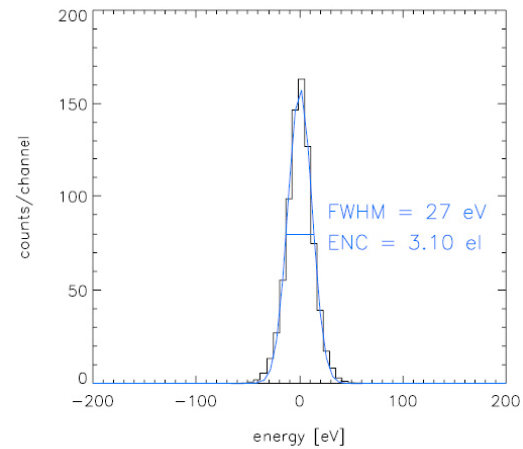
# ● n irradiated - Spectroscopic performance



- Leakage around  **$8.9\text{e}/\mu\text{s}$  @  $23^\circ\text{C}$**
- At low temperatures the performance is similar to unirradiated structures!



- n irradiated - Fe55 spectrum



**T=6 $\mu$ s T=6°C**

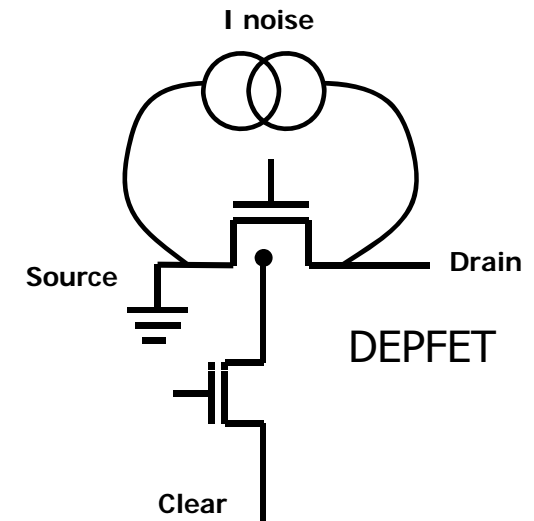
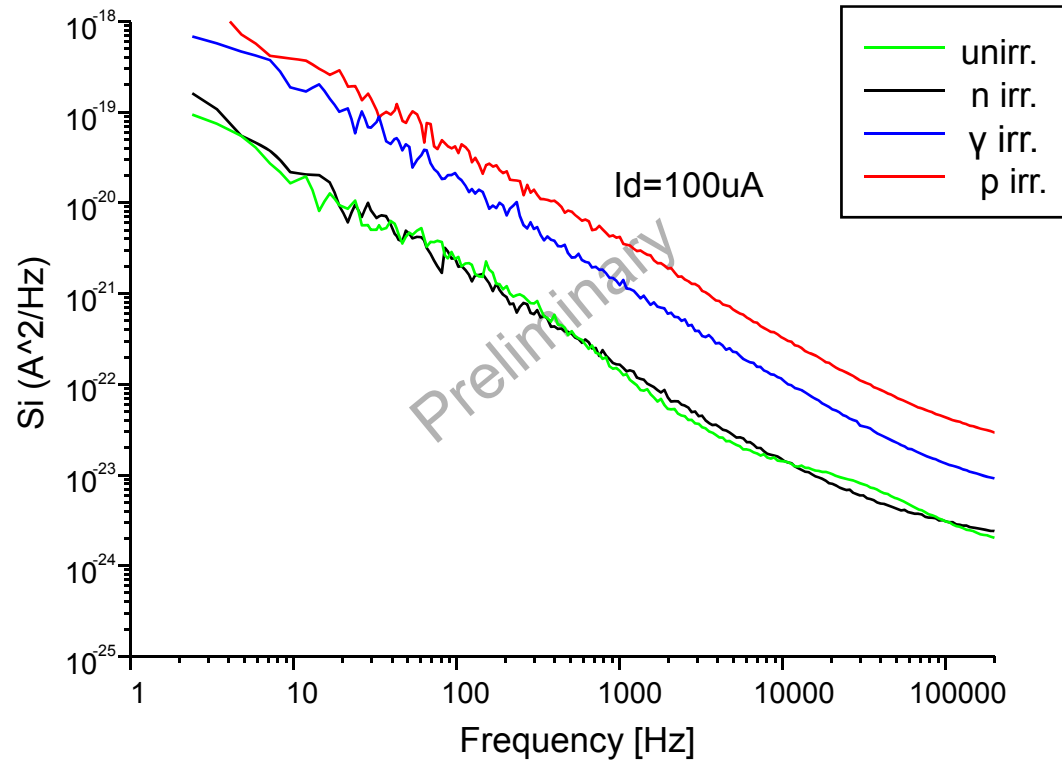
**ENC<sub>noi</sub> = 3.1 e<sup>-</sup>**

## ● n - Irradiation - Summary



- Transistor performance unchanged
- No interface damage observed
- Good spectroscopic performance

# ● Noise power density



- Corner frequency increased
- Expectation from sub threshold slope are confirmed

## ● Conclusion



- Irradiated structures are operable after irradiation
- Threshold voltage shift is in an acceptable region
- Both structures show good spectral resolution
- Noise power density behaves as expected from sub threshold slope
- **The DEPFET double pixel structure could be considered as radiation hard with respect to the ILC requirements**

## ● Leakage current



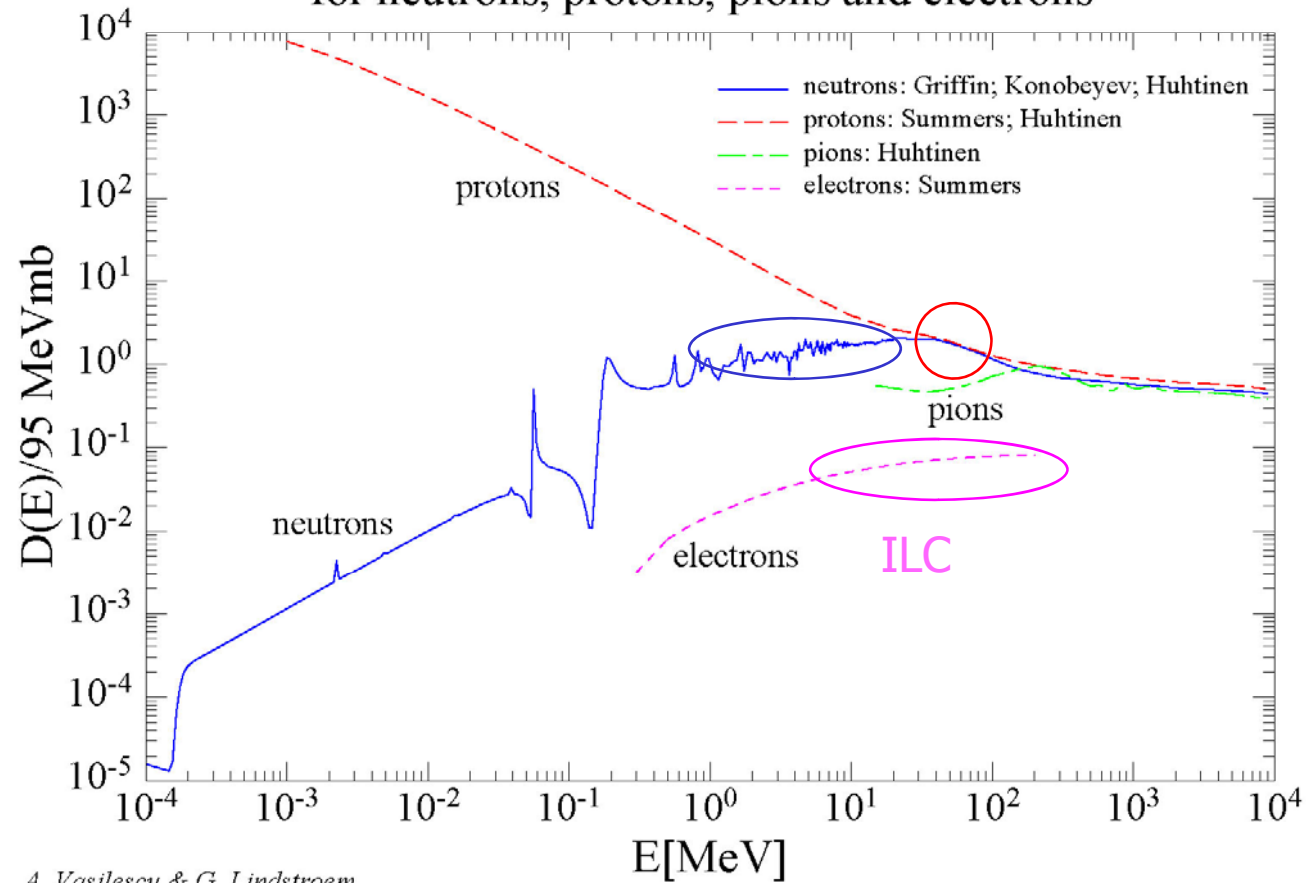
- Leakage current into the internal gate
- Contributions from bulk and surface
- Additional shot noise

@RT

Unirradiated	Gamma	Neutron	Proton
Typ. 20fA	200fA	1.4pA	25.9pA

- NIEL - Bulk damage

Displacement damage in Silicon  
for neutrons, protons, pions and electrons



A. Vasilescu & G. Lindstroem

## ● Shaper measurement vs. CDS



	Continuous shaping ( time invariant)	Time dependent shaping
White noise	$\sqrt{\alpha \frac{2kT}{g_m} C_{tot}^2 A_1 \frac{1}{\tau}}$	$\sqrt{4kT \frac{2}{3} \frac{g_m}{g_g^2} NBW}$
1/f noise	$\sqrt{2\pi a_f C_{tot}^2 A_2}$	$\sqrt{a_f \frac{g_m^2}{g_q^2} 2 \int_0^\infty \frac{1 - \cos(2\pi x)}{x(1+x^2)} dx}$
Shot noise - leakage	$\sqrt{I_L A_3 \tau}$	$\sqrt{I_L T_{frame}}$

ENC depends on:

- Shaping time
- Response function
- Frame time
- Bandwidth
- CDS time

•Both variants are sensitive to the same noise sources, but in different extend

## ● Influence of the radiation



- NIEL (Non Ionizing Energy Loss)
    - Mainly damage to the bulk
  - Ionizing Energy Loss ( charged particles)
    - Damages interface and bulk
- 
- Macroscopic effects:
    - Shift in threshold voltage
    - Increase of leakage current – bulk and interface
    - Increase of 1/f noise
    - Change in effective doping